

[10191/3980]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Franz LAERMER  
Serial No. : 10/519,724  
Filed : December 28, 2004  
For : DEVICE AND METHOD FOR THE PRODUCTION OF  
CHLORINE TRIFLUORIDE AND SYSTEM FOR  
ETCHING SEMICONDUCTOR SUBSTRATES USING  
THIS DEVICE  
Examiner : Rakesh Dhingra  
Art Unit : 1763  
Confirmation No. : 5180

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on:

Date: February 5, 2008

Signature: /Clifford A. Ulrich/ (Reg. No. 42,194)  
Clifford A. Ulrich

**RESPONSE**

S I R:

In response to the Office Action of October 1, 2007, kindly amend the above-captioned application without prejudice as follows:

**Remarks** begin on page 2 of this paper.